E UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant :Hisashi Ohtani et al

Art Unit : Examiner : 1765

Robert Kunemund

: August 1, 1996

: METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE

Applicant : Hisashi Oh Serial No.:08/690,747

Applicant : August 1, 190

Title : METHOD FO commissioner for Patents /Washington, D.C. 20231

TRANSMITTAL LETTER AND PETITION FOR AUTOMATIC EXTENSION

Correspondence relating to this application is enclosed.

The required fees are computed below. Please apply any charges not covered, or any credits, to Deposit Account No. 06-1050.

Total Claims	62 - 13 -	62 13	=	0 0	\$0 \$0
Independent 13 - 13 = First Presentation of Multiple Dependent Claims					\$0
Applicant hereby petitions under 37 C.F.R. §1.136 for a 2 month extension of time.					\$400 \$400
TOTAL FEE DUE					5400

A check for \$400 is attached,

RECEIVED

FEB 1 9 2002

TC 1700

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, Washington, D.C. 20231.

Date pf Deposit Signature

Person Typed or Printed Name of

Certificate

Appl > nt: Hisashi Oht et al Attorney's Docket N 07977-052001 / US3053*
Ser. Jo.: 08/690,747

File August 1, 1996

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Respectfully submitted, Lonald Kordich 109. No. 38,213

For Scott C. Harris Reg. No. 32,030

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